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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Yi-Shung CHAUG, *et al.*

Appl. No. 10/665,992

Filed: September 19, 2003

For: PROCESS FOR FORMING A
PATTERNED THIN FILM
STRUCTURE FOR IN-MOLD
DECORATION

Art Unit: 1762

Confirmation No.: 5386

Examiner: Parker, Frederick John

Attorney Docket: 07783.0101.CPUS01

RESPONSE TO OFFICE ACTION

MAIL STOP: AMENDMENT

Commissions for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

This is in response to the Office Action dated May 9, 2005, and is submitted on or before the due date of **June 9, 2005**.

The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, including fees under §1.17; or credit any overpayment, to our Deposit Account No. 08-3038 referencing Atty. Dkt. No. 07783.0101.CPUS01.